

# Notice of References Cited

Application No.

09/388,989

Applicant(s)

Cohen et al

Examiner

M.L. Padgett

Group Art Unit

1762

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## U.S. PATENT DOCUMENTS

*		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A						
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## FOREIGN PATENT DOCUMENTS

*		DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
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O							
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R							
S							
T							

## NON-PATENT DOCUMENTS

*		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U		Translation of JP 56-153,526 to Yamazaki et al "coating film formation Method"	12/1/81
V			
W			
X			

\* A copy of this reference is not being furnished with this Office action.  
(See Manual of Patent Examining Procedure, Section 707.05(a).)

M.L. Padgett 9/15/03